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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818
Examiner: Chuong A. Luu
Confirmation No.: 6341

In RePATENT APPLICATION Of:

Applicant:

Noriko Tomita et al.

Serial No.:

10/660,490

Filed:

September 12, 2003

For:

SEMICONDUCTOR SUBSTRATE

SURFACE PROTECTION METHOD

Attny Ref.:

OHG 135

AMENDMENT

and

PETITION for extension of time

April 3, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is in response to the Official Action mailed on December 2, 2005. Payment for one month's extension of time is attached. Please charge our Deposit Account No. 18-0002 if any additional fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but this paper is a petition for extension of time.

The amendment to recite "leaving the substrate to stand in air containing ambient organic substances" is supported in claim 20, in the specification at page 1, line 26 to page 2, line 3, and in claim 23 (the word "ambient").

I certify that this correspondence is being facsimile transmitted to the United States
Patent and Trademark Office (fax no. 571-273-8300) on April 3, 2006.

Nick Bromer [reg. no. 33,478]

Signature Nick Browner

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